Application No.: 09/943,955 JUN 1 3 Mocket No.: 5918/FPS/MMCS/APC/DV

PATENT/OFFICIAL

IN THE UNITED TRADE TRAD Umez Eronini, L.T. Examiner: Serial No. 09/943,955 Group Art Unit: 1765

Filed: August 31, 2001

FEEDBACK CONTROL OF CHEMICAL MECHANICAL POLISHING DEVICE For: PROVIDING MANIPULATION OF REMOVAL RATE PROFILES

CERTIFICATION UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelop addressed to: Mail Stop: Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below

6-9-05 Date of Deposit

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

NOTICE OF APPEAL

Dear Commissioner:

Applicants hereby appeal the rejection of claims 1-17 and 21-24 in the above-identified application from the last Examiner Communication, which was Final Office action dated December 30, 2004. Please charge the fees set forth in 37 C.F.R. 1.17 to our Deposit Account No. 02-0819. If there are any charges or any credits, please apply them to Deposit Account No. 02-0819.

Respectfully submitted,

Date: June 9 2005

Reg. No. 36,268

Wilmer Cutler Pickering Hale and Dorr LLP

60 State Street

Boston, MA 02109 Tel: (617) 526-6015

Fax: (617) 526-5000

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